Evolution of the electric potential of an insulator under charged particle impact

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Insulating glass capillaries have been shown to lead to ion transmission without any change in either the ion charge state or in the ion kinetic energy. This surprising process has been attributed to a self-organized distribution of charge patches creating the necessary guiding electric potential on the capillary walls. By the use of our original electrometer, it has been possible to measure and monitor simultaneously and in a nondestructive way the electric potential and the transmitted beam intensity during the charging up by an Ar$^+$ ion beam. We show that glass microcapillaries can reach potentials higher than 500 V, even in the case of singly charged ions, opening the possibility of high transmission rates and providing a renewed sight into ion beam transport by tapered capillaries. The setup, also suitable for the determination of leakage currents governing the capillary potential dynamics, allowed one to evidence that secondary electrons may strongly affect the rise of the capillary potential and consequently avoid Coulomb blocking of the beam transmission across insulating capillaries.

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Under charged particles impact, insulator surfaces accumulate electric charges, generating an electric field that, if sufficiently strong, prevents the following beam particles to hit the insulator surface. This basic property led to the discovery that slow ions can pass through insulator capillaries, keeping their initial charge state even when the geometrical conditions do not allow it [1]. The phenomenon is called charged particle guiding by insulators and it has become an intensively studied field since its discovery [2–25]. The basic concept is the transmission of charged particles through insulating capillaries under incident angles much larger than the geometrical transmission due to the self-organized formation of charge patches at the inner wall that guide the ions. Taking advantage of the existing knowledge with insulating capillaries, a unique experimental technique was developed for the investigation of charging and discharging processes in insulating surfaces. The technique is based on the combination of slow ions and a conical-shape insulator glass capillary and allows following in time the accumulated charge in the capillary with a sensitivity of 20 pC. Alternatively, it allows measuring leakage currents in the femtoampere range.

When an ion beam is injected into a tapered glass capillary, most of the injected charge is stored in the dielectric and its electric potential rises. How exactly the potential evolves is difficult to monitor, which may explain why the potential of charged capillaries is hardly mentioned in the literature in the analysis of the transmission of tapered capillaries. Also, the inner resistance of most electrometers is lower or comparable to that of a glass capillary and would spuriously discharge the capillary. However, knowing the transmission rate as a function of the capillary potential, is crucial for the understanding of the charge dynamics in capillaries. For example, it allows one to identify if a possible blocking of the transmission is indeed due to Coulomb blocking, by comparing the potential of the capillary to the extraction potential of the ions. A recent theoretical study showed that the transmission through conical-shaped capillaries increases strongly when the self-organized electric potential approaches about 80% of the extraction potential of the ion source, as the focal point is moved from infinity to the exit of the capillary [24]. For a low enough beam emittance, transmission rates of a factor 20 well above the geometrical one are expected, boosting the interest of ion beam transport by conical-shaped glass capillaries. Thus, linking the transmission rate to the capillary potential will allow one to identify the critical moment where a significant increase of the intensity can be expected. We present a setup and a technique, able to monitor simultaneously the time evolution of the electric potential and the transmitted beam intensity of a tapered capillary during the charging up, in a nondestructive way. We expect this original technique to be particularly useful to the community of capillaries, as the potential of the capillary was often a missing brick for the interpretation of the results. Meanwhile, this study also evidences that stray electrons can be a strong discharge mechanism that helps to stabilize the electric potential and avoiding Coulomb blocking. Eventually, it permits one to quantify the leakage current due to stray electrons during the charging process.

We use a borosilicate glass microcapillary of 75 mm length, whose first segment of 35 mm is cylindrical, while the end was conical shaped. The inner diameter of the outlet of our conical capillary is 26 μm and is 33 times smaller than the...
inner diameter of the inlet (860 μm). The entrance of the capillary, in electric contact with the inlet collimator hole of 600 μm diameter, is on ground potential. This results in a geometrical transmission fraction of less than 0.2%. The outer surface of the capillary is covered with a conductive layer (silver paint), except for 3 mm behind the entrance (see Fig. 1), which acts as a resistor of \((1.1 \pm 0.2) \times 10^{15} \, \Omega\). The outer metallic surface, of an estimated capacity of 0.9 pF, was connected by a thin copper cable of negligible capacity to a plate electrode placed behind the capillary exit, which was acting as a deflector with its grounded pair. The deflector plates have a surface of 9 cm² and are separated by 1 cm, giving an estimated capacity of about 0.8 pF, if ignoring any border effects. The upper (connected) deflection plate is maintained by a resistor of \((7.5 \pm 0.1) \times 10^{14} \, \Omega\). Both resistances were measured at room temperature and at a pressure below 10⁻⁶ mbar. The conductive layer could be connected to an ammeter or, according to our experimental conditions, kept floating. The experimental chamber is equipped with a high precision rotatable and translational capillary holder and a position sensitive detector (PSD), using a microchannel plate and delay line anode located 400 mm behind the deflector plates. Inside the holder, the capillary is fixed mechanically. The measurements were performed at the CIMP laboratory in Caen, France. For the experiments, we used 3 kV Ar⁺ ions produced by an ion gun. For the charging, the intensity of the incoming ion beam was varied between 0.4 and 16 pA. The beam divergence is estimated to be less than 0.3°. The capillary axis was aligned with the beam. The injected current \(I\) was measured precisely before charging up and after discharging, by connecting the outer electrode to an ammeter. Indeed, in this configuration, the outer metal layer behaves like a Faraday cup.

The main purpose here is to monitor the electric potential of a tapered capillary during the charge-up process in a nondestructive way. The key idea is to keep the potential of the upper deflection plate, connected to the metallized outer capillary surface, floating. The charge-up and the discharge processes are competing. One is the charging of the capillary due to the incoming ion beam of intensity \(I\). The other one is the leakage current, controlled by the equivalent resistance \(R = (4.4 \pm 1.4) \times 10^{14} \, \Omega\) of the two resistors (in parallel) between the grounded and floating electrodes. Let \(C \approx 1.7 \, \text{pF}\) be the capacity of the deflector plates in parallel with the capillary metal surface and \(U\) their potential. The equivalent circuit of the setup is given in Fig. 2. We label \(t_0 = CR\) the characteristic discharge rate of the capacitor through the resistance \(R\). An ion beam of intensity \(I\) is injected into the glass capillary and a small fraction of the beam is transmitted through the capillary immediately, while the dominant fraction of the beam hits the inner surface, accumulating the charge on the inner wall. Because of the low geometrical transmission (< 0.2%), the deposited charge \(dQ'\) per unit time \(dt\) at the inner surface is safely approached by \(dQ' = I \, dt\). As the outer metal layer covers almost all the capillary, the inner and outer surfaces of the capillary are in total influence. Consequently, the charge stored in the glass is distributed on the electrodes. From the circuit, one deduces that the potential \(U\) of the floating outer metallic layer and upper deflection plate rises in time like \(U(t) = I \, R \{1 - \exp(-t/t_0)\}\), generating thus an increasing electric field between the deflector plates. The transmitted ions are deflected by the electric field on a PSD. From the impact position on the detector, we were able to deduce the potential of the target from a previously generated look-up table. Once the incoming beam current and the leakage currents are equal, a stable potential (i.e., a stable deflection) is observed on the detector.

In our chamber, the capillary was initially not shielded from secondary electrons, produced by the ion impacts on metallic parts. As a consequence, the charging dynamics of the capillary was strongly affected by stray electrons, which were captured by the positive potential of the capillary and upper deflector plate, giving rise to a spurious discharge channel. This channel was so strong that the capillary stayed at a low potential. To reduce the neutralization channel due to stray electrons, the capillary holder was wrapped in aluminum foil. We could, however, only achieve a partial shielding. First, the deflection plate was understandably not shielded and could still attract stray electrons, once its potential rose. Second, stray electrons could still slip through the 1-mm gap below the collimator plate, bypassing the shielding. Nevertheless, after the partial shielding, the discharge rate of the channel was decreased strongly, allowing finally the rise of the capillary potential. The injected secondary electrons current at the outer metallized capillary surface now no longer exceeded the injected beam current \(I\), while still dominating the extremely low leakage current of an electrically isolated capillary. Eventually this permitted us to evidence the sensitivity of the capillary potential to stray electron neutralization.

As the secondary electrons are not fully suppressed, we add a depletion channel accounting for the secondary electrons that are injected at the positive but floating electrodes. The injected electron current is estimated using the following assumptions: First, we assume that the secondary electrons that are possibly
injected at the electrodes, bypassing the incomplete shielding, are mostly produced by the beam ions that hit the collimator plate in front of the capillary. This electron current is thus taken proportional to the injected ion beam current $I$, with $k > 0$ being the proportionality factor, depending mainly on the screening. Second, we assume that with increasing potential, more and more electrons are attracted toward the electrodes. We assume that its probability increases linearly for low potentials and that there exists a threshold potential $U_c$ where all available electrons are injected at the electrodes. The probability that satisfies both requirements may be expressed by an error function, $0 \leq \text{erf}(U/U_c) < 1$, and the time evolution of $U$ is eventually given by

$$C \frac{\partial U}{\partial t} = I - \frac{U}{R} - kI \text{erf}(U/U_c). \quad (1)$$

The solution of the above equation may be obtained analytically for the two cases where $U \ll U_c$ and $U \gg U_c$. If the potential $U$ is sufficiently low compared to $U_c$, $k \text{erf}(U/U_c) \simeq \frac{2k}{\sqrt{\pi}U_c} U = \alpha U$, then Eq. (1) reduces to

$$\frac{\partial U}{\partial t} = \frac{I}{C} - \left( \frac{1}{\tau_0} + \frac{\alpha I}{C} \right) U. \quad (2)$$

Its solution is given by

$$U(t) = U_0 e^{-t/\tau} + \frac{I \tau}{C} (1 - e^{-t/\tau}), \quad (3)$$

where we define the characteristic time scale $\tau$ and the initial potential by $U_0$,

$$\tau \equiv \tau(I) = \frac{\tau_0}{1 + \alpha RI} \quad \text{and} \quad U_0 = U(t = 0). \quad (4)$$

Equation (3) fits both charging and discharging of the capillary in the presence of secondary electrons. Within these assumptions, the asymptotic potential that is reached during charge-up,

$$U(t \to +\infty, I) = \frac{RI}{1 + \alpha RI}, \quad (5)$$

increases with the input current $I$. However, for larger input currents, the assumption that $U$ is small compared to $U_c$ may no longer be valid. The probability $\text{erf}(U/U_c)$ tends asymptotically to 1 when $U$ is larger than $U_c$ and Eq. (1) resums to

$$\frac{\partial U}{\partial t} = \frac{I(1 - k)}{C} - \frac{U}{\tau_0}. \quad (6)$$

Its solution is

$$U(t) = R I (1 - k)(1 - e^{-t/\tau_0}) + U_0 e^{-t/\tau_0} \quad \text{in this case, the asymptotic potential, which is reached during charge-up, now becomes}$$

$$U(t \to +\infty, I) = R I (1 - k). \quad (7)$$

It increases linearly with the beam intensity $I$, where the slope depends on $k$, which is essentially the screening of the electrodes from the secondary electrons. In the case of very low input currents $I \to 0$, Eq. (4) shows that $\tau(I)$ tends asymptotically to the characteristic time $\tau_0$, from which the resistance $R$ or capacity $C$ may be deduced, if one of them is known.
a conical borosilicate capillary of estimated capacity of 1 pF, beam current as well as the neutralization channel due to was initiated by reducing the injected beam intensity $I$ about 10 fA. For such small injected intensities, the leakage currents during the capillary charge-up. We clearly show that, if the capillary is not sufficiently screened from secondary electron sources, stray electrons hinder the potential of the capillary to approach the extraction potential of the ions. However, this secondary electron channel might have allowed other authors to inject strong beam currents into tapered glass capillaries without experiencing Coulomb blocking. Finally, this technique may be used to evaluate the screening of the capillary from stray electrons in experimental setups.

In conclusion, we used the deflection of the transmitted beam as an ideal electrometer to monitor the potential of an insulating surface, which in our recent case was the inner surface of the tapered glass capillary, under charged particle impacts as a function of time. Simultaneously we recorded the transmitted beam intensity. Measuring the potential of the capillary while following the transmitted beam intensity is of great interest for the community of capillaries. It may indeed be helpful to identify if the blocking of the transmission is due to Coulomb blocking or if the blocking happened because, for example, the beam is deviated away from the exit by charge patches due to the mismatch of the capillary axis with the beam axis or the asymmetries of the capillary. The technique is also helpful for identifying if and when the capillary reaches the critical potential where it starts to act as an electrostatic lens, opening a pathway to control the transmission rate by the change of the capillary potential, in a self-organized manner. Our measurements show that, despite the neutralization channel due to stray electrons, a tapered glass capillary is able to accumulate enough charge to generate electric potentials that go beyond 600 V. This is encouraging for the study of the lens effect of capillaries as, with a better screening, we expect the potential to easily access the kilovolt range. Last but not least, with the help of a simple model, we were able not only to identify but also to quantify the leakage currents during the capillary charge-up. This work was funded by the French National Research Agency (ANR) in the P2N 2012 program (ANR-12-NANO-008) for the PELIICAEN project. This work was also supported by TéT Grant No. TéT 12 FR-1-013-0007, by Hungarian Scientific Research Fund OTKA No. NN 103279, and by the European Cost Actions CM1204 (XLIC) and CM1405 (MOLIM). H.Z. acknowledges the financial support by the National Natural Science Foundation of China (Grant No. 11475075).

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